

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Hitoshi ASADA et al.**

Serial Number: **Not Yet Assigned**

Filed: **September 17, 2003**

Customer No.: 23850

For: **SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 17, 2003

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge
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Respectfully submitted,
ARMSTRONG, WESTERMAN & HATTORI, LLP



John P. Kong
Reg. No. 40,054

Atty. Docket No.: 031168
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
Tel: (202) 659-2930
Fax: (202) 887-0357
JPK/yap
Enclosures: PTO-1449; References (4)

**INFORMATION
DISCLOSURE
STATEMENT
PTO-1449**

Atty. Docket No. 031168

Serial No. New Appln.

Applicant(s): Hitoshi ASADA

Filing Date: September 17, 2003

Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AE 6-112219	04/22/94	Japan	Abstract.
_____	AF 9-260590	10/03/97	Japan	Abstract.
_____	AG 11-126900	05/11/99	Japan	Abstract.
_____	AH 11-195789	07/21/99	Japan	Abstract.
_____	AI			

OTHER DOCUMENTS

_____	AJ	
_____	AK	

Examiner

Date Considered